



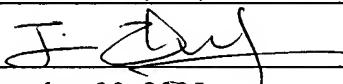
IPW

TRANSMITTAL FORM

(to be used for all correspondence after initial filing)

Application No.	10/656,628	
Filing Date	September 5, 2003	
First Named Inventor	Yoshihide SENZAKI	
Examiner Name	CHEN, Bret P.	
Group Art Unit	1762	
Total Number of Pages in This Submission	9	Attorney Docket No.
		A-71730/MSS (463035-878)

ENCLOSURES (check all that apply)		
<input type="checkbox"/> Fee Transmittal Form <input type="checkbox"/> Fee Attached <input checked="" type="checkbox"/> Amendment / Reply <input type="checkbox"/> After Final <input type="checkbox"/> Affidavits/declaration(s) <input type="checkbox"/> Extension of Time Request <input type="checkbox"/> Express Abandonment Request <input type="checkbox"/> Information Disclosure Statement <input type="checkbox"/> Certified Copy of Priority Document(s) <input type="checkbox"/> Response to Missing Parts/ Incomplete Application <input type="checkbox"/> Response to Missing Parts under 37 CFR 1.52 or 1.53	<input type="checkbox"/> Assignment Papers (for an Application) <input type="checkbox"/> Drawing(s) <input type="checkbox"/> Licensing-related Papers <input type="checkbox"/> Petition <input type="checkbox"/> Petition to Convert to a Provisional Application <input type="checkbox"/> Power of Attorney, Revocation Change of Correspondence Address <input type="checkbox"/> Terminal Disclaimer <input type="checkbox"/> Request for Refund <input type="checkbox"/> CD, No. of CD(s) _____	<input type="checkbox"/> After Allowance Communication to Group <input type="checkbox"/> Appeal Communication to Board of Appeals and Interferences <input type="checkbox"/> Appeal Communication to Group (Appeal Notice, Brief, Reply Brief) <input type="checkbox"/> Proprietary Information <input type="checkbox"/> Status Letter <input type="checkbox"/> Other Enclosure(s) (please identify below):
Remarks		

SIGNATURE OF APPLICANT, ATTORNEY, OR AGENT		
Firm or Individual name	Jamie J. Zheng Dorsey & Whitney LLP 555 California Street, Suite 1000 San Francisco, CA 94104-1513 Telephone No.: (650) 857-1717 Facsimile No.: (650) 857-1288	Customer Number 32940
Signature		
Date	December 30, 2005	

CERTIFICATE OF MAILING		
I hereby certify that this correspondence is being deposited with the United States Postal Service with Sufficient postage as first class mail in an envelope addressed to Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on this date:		12/30/05
Typed or printed name	Laura Lee Mosier	
Signature		Date
		December 30, 2005



A-71730/MSS
463035-878

CERTIFICATE OF MAIL (37 CFR 1.8(a))

I hereby certify that this paper (along with any referred to as being attached or enclosed) is being deposited with the United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Mail Stop AMENDMENT, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on December 30, 2005.

Signed: 
Laura Lee Mosier

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:
Yoshihide SENZAKI *et al.*

Serial No. 10/656,628

Filed: September 5, 2003

For: Low Temperature Deposition Of Silicon
Based Thin Films By Single-Wafer Hot-
Wall Rapid Thermal Chemical Vapor
Deposition

Examiner: CHEN, Bret P.

Group Art Unit: 1762

Date: December 30, 2005

RESPONSE/AMENDMENT

MAIL STOP AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This Amendment is in response to the Office Action dated September 30, 2005. Please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Amendments to the Abstract begin on page 5 of this paper.

Remarks begin on page 6 of this paper.